



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Teruo TAKIZAWA

Group Art Unit: 2826

Application No.: 10/785,073

Examiner: K. Quinto

Filed: February 25, 2004

Docket No.: 118439

For: SEMICONDUCTOR DEVICE INCLUDING P-TYPE SILICON LAYER INCLUDING
IMPLANTED GERMANIUM (AS AMENDED)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 3, 2004 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.